

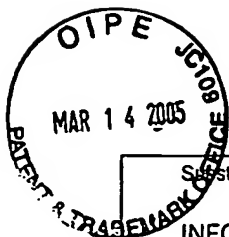


Substitute for form 1449A/PTO <b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  (use as many sheets as necessary)		<b>Complete if Known</b>			
		Application Number	10/806,361		
		Filing Date	March 23, 2004		
		First Named Inventor	Stumbo		
		Art Unit	2811		
Sheet		of		Examiner Name	
				Attorney Docket Number	01-004000

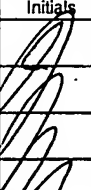
U.S. PATENT DOCUMENTS					
Examiner Initials	Cite No.	Document No.	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, lines, Where Relevant Passages or Relevant Figures Appeal
		Number - Kind Code (if known)			
	AA	US-5,962,863	10/05/1999	Russell et al.	
	AB	US-6,245,767	07/03/2001	Kuekes et al.	
	AC	US-6,447,663	09/10/2002	Lee et al.	
	AD	US-6,566,704	05/20/2003	Choi et al.	
	AE	US-6,586,785	07/01/2003	Flagan et al.	
	AF	US-6,760,245	07/06/2004	Eaton et al.	
	AG	US-6,798,000	09/28/2004	Luyken et al.	
	AH	US-20020117659	08/29/2002	Lieber et al.	
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	AJ	US-20020130311	09/19/2002	Lieber et al.	
	AK	US-20020130353	09/19/2002	Lieber et al.	
	AL	US-20020163079	11/07/2002	Awano	
	AM	US-20020175408	11/28/2002	Majumdar et al.	
	AN	US-20030012723	01/16/2003	Clarke	
	AO	US-20030042562	03/06/2003	Giebeler et al.	
	AP	US-20030089899	05/15/2003	Lieber et al.	
	AQ	US-20030186522	10/02/2003	Duan et al.	
	AR	US-20030189202	10/09/2003	Li et al.	
	AS	US-20040036126	02/26/2004	Chau et al.	
	AT	US-20040061422	04/01/2004	Avouris et al.	
	AU	US-20040112964	6/17/2004	Empedocles et al.	

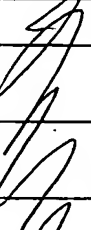
Examiner Signature		Date Considered	2/06
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.



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				Attorney Docket Number	01-004000

FOREIGN PATENT DOCUMENTS						
Examiner Initials	Cite No.	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T
		Country Code - Number - Kind Code (if known)				
	AV	WO-0103208	1/11/2001	Harvard		
	AW	WO-0217362	2/28/2002	Harvard		
	AX	WO-0248701	6/20/2002	Harvard		
	AY	WO-2004032193	04/15/2004	Nanosys		

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS				
Examiner Initials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and-or country where published.		T
	AZ	Chung et al., "Silicon nanowire devices" Appl. Phys. Letts. (2000) 76(15):2068-2070		
	BA	Duan et al., "High performance thin-film transistors using semiconductor nanowires and nanoribbons" Nature (2003) 425:274-278		
	BB	Tans et al., "Room-temperature transistor based on a single carbon nanotube" Nature (1998) 393:49-52		
	BC	Yamada "Analysis of submicron carbon nanotube field-effect transistors" Appl. Phys Letts (2000) 76(5):628-630		

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